

# Lecture 17: Capacitance, Resistance, and the Method of Images

ECE221: Electric and Magnetic Fields



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# Outline

- 1 Relationship Between Resistance and Capacitance
- 2 Resistance Examples
- 3 Method of Images

## Resistance and Capacitance

$$R = \frac{V}{I} = \frac{-\int_C \mathbf{E} \cdot d\mathbf{l}}{\int_S \sigma \mathbf{E} \cdot d\mathbf{s}}$$

$$C = \frac{\int_S \epsilon \mathbf{E} \cdot d\mathbf{s}}{-\int_C \mathbf{E} \cdot d\mathbf{l}}$$

$$RC = \frac{\cancel{-\int_C \mathbf{E} \cdot d\mathbf{l}}}{\int_S \sigma \mathbf{E} \cdot d\mathbf{s}} \times \frac{\int_S \epsilon \mathbf{E} \cdot d\mathbf{s}}{\cancel{-\int_C \mathbf{E} \cdot d\mathbf{l}}} = \frac{\epsilon \int_S \mathbf{E} \cdot d\mathbf{s}}{\sigma \int_S \mathbf{E} \cdot d\mathbf{s}} = \boxed{\frac{\epsilon}{\sigma} = RC}$$

if  $\epsilon$  &  $\sigma$  are  
uniform with position.

## Procedure for Solving for Resistance

- ① Choose a suitable coordinate system.
- ② Solve for the electric field in the region of interest (resistive material region)
  - Find  $\mathbf{E}$  from  $Q$  or  $\rho_v|_{s|l}$  using Gauss' Law or Coulomb's Law; or
  - Find  $V$  from solving Laplace's equation, and find  $\mathbf{E} = -\nabla V$ .

$$\} \vec{J} = \sigma \vec{E}$$

- ③ Find  $I$ :

$$I = \iint \mathbf{J} \cdot d\mathbf{s}$$

- ④ Determine

$$R = \frac{V_0}{I}$$

$$\vec{E} = -V_0/d \hat{z} \rightarrow \vec{J} = \sigma \vec{E}$$

$$= -\frac{\sigma V_0}{d} \hat{z}$$

$$I = \iint_S \vec{J} \cdot d\vec{S} = \iint -\frac{\sigma V_0}{d} \hat{z} \cdot (-\hat{z}) dy dx$$

$$= \frac{\sigma V_0 A}{d} = I$$

$$R = V_0/I = V_0 / \frac{\sigma V_0 A}{d}$$

$$R = \frac{d}{\sigma A}$$

match!

$$R = \frac{l}{\sigma A}$$

only applies when  $\vec{E}/\vec{J}$  is uniform in resistive region.

## Parallel Plate Capacitor/Resistor

$C$  remains unchanged if  $\sigma \neq 0 \rightarrow$  now there's resistance btw two plates.

direction of  $d\vec{S}$

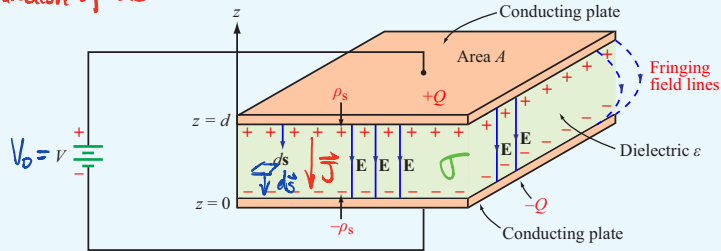
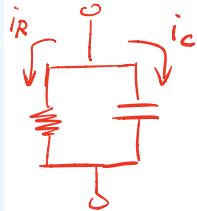


Image Credit: Ulaby and Ravaioli



In parallel.

$$RC = \frac{\epsilon}{\sigma} \rightarrow R = \frac{\epsilon}{\sigma C} \quad \text{Recall } C = \frac{\epsilon A}{d} \Rightarrow R = \frac{d}{\sigma A}$$

matches

## Coaxial Capacitor/Resistor

Recall  $\vec{E} = -\frac{\hat{r} V_0}{\rho \ln(b/a)}$

$$I = \iint \vec{J} \cdot d\vec{s} = \iint -\frac{\hat{r} \nabla V_0}{\rho \ln(b/a)} \cdot d\vec{s} = \frac{\cancel{\rho} \nabla V_0}{\cancel{\rho} \ln(b/a)} \cdot \cancel{\rho} d\phi d\cancel{z} \quad (-\cancel{r})$$

$$= \frac{\nabla V_0}{\ln(b/a)} 2\pi l$$

$$R = \frac{V_0}{I} = \frac{\ln(b/a)}{\nabla 2\pi l} = \frac{1}{G} \quad G = \frac{2\pi \nabla l}{\ln(b/a)}$$

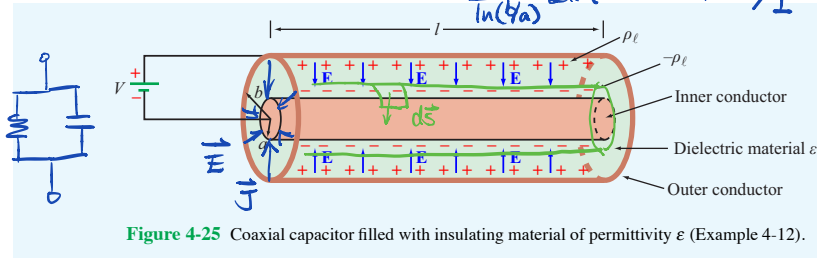


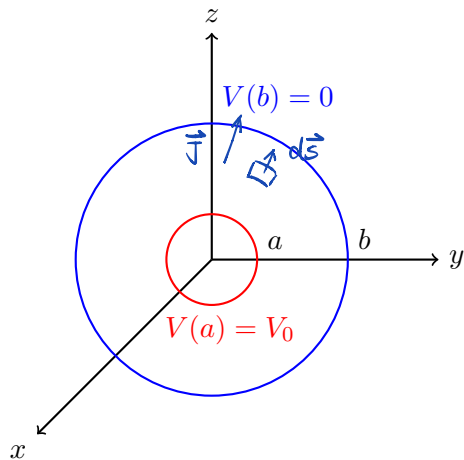
Figure 4-25 Coaxial capacitor filled with insulating material of permittivity  $\epsilon$  (Example 4-12).

Image Credit: Ulaby and Ravaioli

$$G' = G \text{ per unit length} = \frac{G}{l}$$

$$G' = \frac{2\pi \nabla}{\ln(b/a)} \left[ \frac{1}{\Omega \cdot m} \right] \text{ or } \left[ \frac{S}{m} \right]$$

## Spherical Capacitor/Resistor



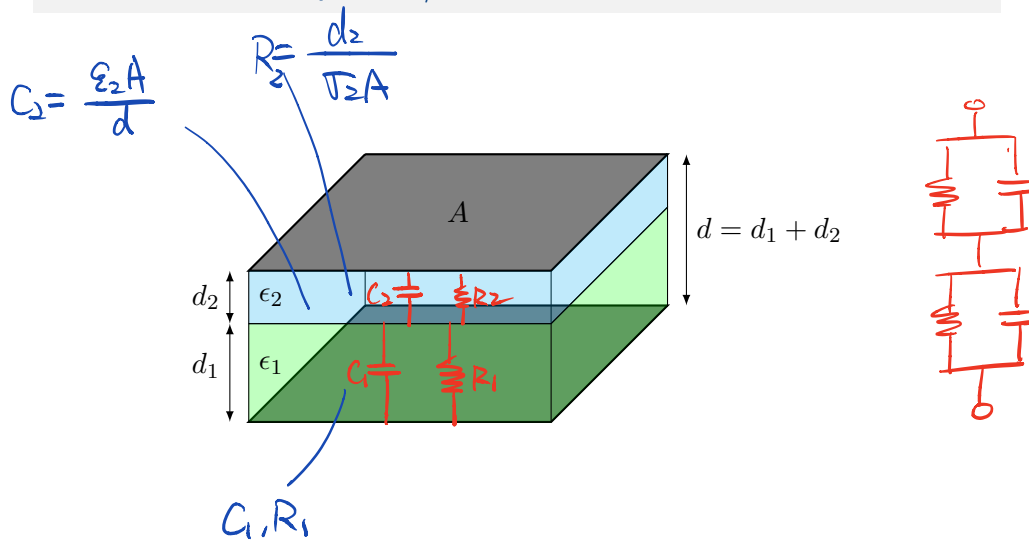
Recall:  $\vec{E} = \hat{r} \frac{V_0}{r^2} \frac{1}{\frac{1}{a} - \frac{1}{b}}$

$$I = \int_0^{2\pi} \int_0^\pi \cancel{\hat{r}} \frac{\nabla V_0}{\cancel{r^2}} \frac{1}{\frac{1}{a} - \frac{1}{b}} \cdot (\cancel{\hat{r}} \cancel{r^2} \sin\theta d\theta d\phi)$$

$$= \frac{\nabla V_0}{\frac{1}{a} - \frac{1}{b}} (4\pi)$$

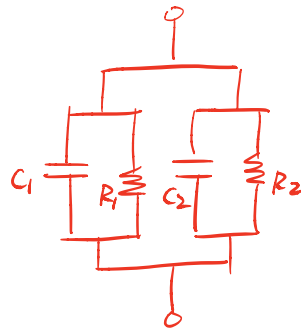
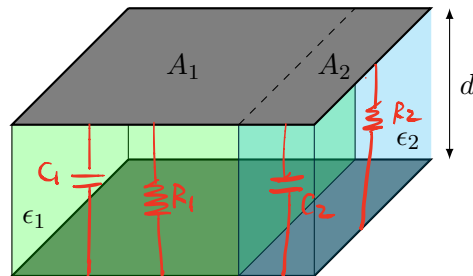
$$R = \frac{V_0}{I} = \frac{\frac{1}{a} - \frac{1}{b}}{4\pi \nabla}$$

# Parallel Plate Capacitor/Resistor: Case 1



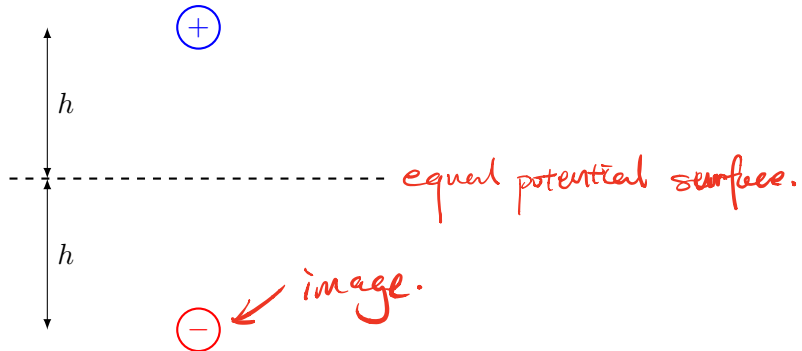


## Parallel Plate Capacitor/Resistor: Case 2



## Method of Images

Given a charge configuration above an infinite grounded PEC plane may be replaced by the charge configuration itself, its image, and an equipotential surface in place of the conducting plane.



# Method of Images

